

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Takahiro KASUGA et al.

Appln. No.:

Filed: Herewith

For: A SEMICONDUCTOR DEVICE AND A METHOD OF MANUFACTURING  
THE SAME

\* \* \*

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

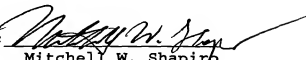
Sir:

Without any assertion of materiality or prior art effect, Applicants wish to make record the documents cited in predecessor Application Nos. 10/123,242 filed April 17, 2002 and 09/920,942 filed August 3, 2001, whether cited by Applicants or by the Patent Office. The documents are listed on the attached Form-1449 as Documents AA-AM on sheet 1.

Applicants also wish to make of record Documents AA\*-  
AD\* (copies provided herewith) which were cited in related  
Application No. 10/325,908 filed December 23, 2002.

Respectfully submitted,

MWS:jab

By:   
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July 25, 2003

FORM PTO-1449		Atty. Docket No. <b>XA-9524C</b>	Appln. No.
<b><u>LIST OF DOCUMENTS CITED BY APPLICANT</u></b>		Applicant <b>Takahiro KASUGA et al.</b>	
		Filing Date <b>HEREWITH</b>	Group

## U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date
	AA	6,399,423	6/2002	Matusura et al.	438	123	
	AB	5,750,153	5/1998	Shibata	425	116	
	AC	5,645,864	7/1997	Higuchi	425	116	
	AD	6,028,774	2/2000	Shin et al.	361	764	
	AE	5,977,613	11/1999	Takata et al.	257	666	
	AF	6,469,369	10/2002	Lee	257	670	
	AG	6,238,953	05/2001	Tanaka et al.	438	112	
	AH	5,753,532	05/1998	Sim	438	112	
	AI	5,684,327	11/1997	Nakazawa et al.	257	667	
	AJ	4,894,704	01/1990	Endo	257	667	

## FOREIGN PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Country	Class	Sub-class	Translation
	AK	5-326799	12/10/93	Japan			Abstract
	AL	2000-61989	02/29/00	Japan			Abstract
	AM	5-299455	11/12/93	Japan			Abstract
	AN						

OTHER (including author, title, date, pertinent pages, etc.)

Examiner		Date Considered	
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.			

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		Filing Date <b>HEREWITH</b>	Group

## U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date
	AA*	6,341,549	01/2002	Kim	83	942	
	AB*	6,303,983	10/2001	Koike	257	670	
	AC*	5,473,189	12/1995	Nakanishi	257	670	
	AD*	5,766,649	06/1998	Azuma	425	116	
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						

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